

U.S. Department of Commerce, Patent and Trademark Office

Docket No.:

4260/P1/CMP/CMP/RKK

Serial No.:

09/843,582

LIST OF RELEVANT ART CITED BY APPLICANT

(Use several sheets if necessary)

Applicants:

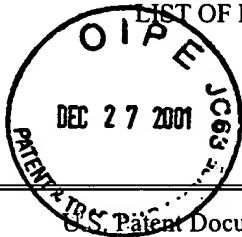
Yuchun Wang, Rajeev Bajaj and Fred C. Redeker

Filing Date:

4/26/01

Group: 3723

unknown



U.S. Patent Documents

| *Examiner Initial | | Document Number | Issue Date | Name | Class | Subclass | Filing Date If Appropriate |
|-------------------|----|-----------------|------------|------|-------|----------|----------------------------|
| | AA | | | | | | |
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Foreign Patent Documents

Translation

| | | Document Number | Date | Country | Class | Subclass | Yes | No |
|-----|----|-----------------|----------|---------|-------|----------|-----|----|
| DVN | AL | 00/44034✓ | 07/27/00 | World | | | | |
| | AM | | | | | | | |
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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| | AR | |
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Examiner

Date Considered

Jimmy van Nguyen

2-20-2002

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

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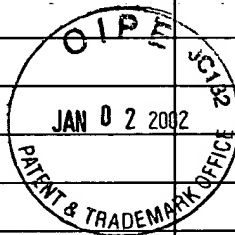
April 26, 2001

Group:

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U.S. Patent Documents

| *Examiner Initial | | Document Number | Issue Date | Name | Class | Subclass | Filing Date If Appropriate |
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| DVN | AA | 6,022,264✓ | 02/08/00 | Cook et al. | | | |
| DVN | AB | 6,022,268✓ | 02/08/00 | Roberts et al. | | | |
| | AC | | | | | | |
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Foreign Patent Documents

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| DVN | AA | 4,169,337✓ | 10/02/79 | Payne | | | |
| | AB | 4,588,421✓ | 05/13/86 | Payne | | | |
| | AC | 4,752,628✓ | 06/21/88 | Payne | | | |
| | AD | 4,867,757✓ | 09/19/89 | Payne | | | |
| | AE | 5,264,010✓ | 11/23/93 | Brancaleoni et al. | | | |
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| | AK | 5,769,689✓ | 06/23/98 | Cossaboon et al. | | | |

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| DVN | AL | 98/49723✓ | 11/05/98 | World | | | | |
| | AM | 0 913 442 A2✓ | 05/06/99 | Europe | | | | |
| | AN | 00/30159✓ | 05/25/00 | World | | | | |
| | AO | 00/36037✓ | 06/22/00 | World | | | | |
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| | | | | | Applicants: Yuchun Wang, Rajeev Bajaj and Fred C. Redeker | | | |
| | | | | | Filing Date: April 26, 2001 | | Group: 3723 | |

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| dvw | AA | 5,840,629✓ | 11/24/98 | Carpio | | | |
| | AB | 5,876,508✓ | 03/02/99 | Wu et al. | | | |
| | AC | 5,911,835✓ | 06/15/99 | Lee et al. | | | |
| | AD | 5,932,486✓ | 08/03/99 | Cook et al. | | | |
| | AE | 5,958,794✓ | 09/28/99 | Bruxvoort et al. | | | |
| | AF | 5,981,454✓ | 11/09/99 | Small | | | |
| | AG | 6,033,993✓ | 03/07/00 | Love, Jr. et al. | | | |
| | AH | 6,042,741✓ | 03/28/00 | Hosali et al. | | | |
| | AI | 6,046,110✓ | 04/04/00 | Hirabayashi et al. | | | |
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| dvw | AL | 00/53691✓ | 09/14/00 | World | | | | |
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| DVN | AA | 6,077,337 ✓ | 06/20/00 | Lee | | | |
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| | AC | 6,096,652 ✓ | 08/01/00 | Watts et al. | | | |
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| | AF | 6,117,783 ✓ | 09/12/00 | Small et al. | | | |
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| | AJ | 6,156,661 ✓ | 12/05/00 | Small | | | |
| ✓ | AK | 09/401,643 ✓ | | Li et al. | | | 09/22/99 |

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| *Examiner Initial | Document Number | Issue Date | Name | Class | Subclass | Filing Date If Appropriate | |
| dvN | AA | 09/469,708 ✓ | Li et al. | | | 12/21/99 | |
| | AB | 09/543,777 ✓ | Sun et al. | | | 4/05/00 | |
| | AC | 09/544,281 ✓ | Sun et al. | | | 4/06/00 | |
| | AD | 09/569,968 ✓ | Sun et al. | | | 5/11/00 | |
| | AE | 09/606,544 ✓ | Sun et al. | | | 6/30/00 | |
| | AF | 09/608,078 ✓ | Sun et al. | | | 6/30/00 | |
| | AG | 09/694,866 ✓ | Wang et al. | | | 10/23/00 | |
| | AH | 09/698,863 ✓ | Tsai et al. | | | 10/27/00 | |
| | AI | 09/698,864 ✓ | Sun et al. | | | 10/27/00 | |
| | AJ | 09/741,538 ✓ | Li et al. | | | 12/20/00 | |
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